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PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

NOBUHIRO ITO

Application No.: 09/505,627

Filed: February 16, 2000

For: MANUFACTURING METHOD OF
ELECTRON BEAM APPARATUS
AND SPACER, AND ELECTRON
BEAM APPARATUS

Examiner: J. Williams

Group Art Unit: 2879

March 17, 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT

Sir:

In response to the Notice of Non-Compliant Amendment dated March 10, 2004, attached is the replacement "Amendment to the Claims" section for the reply to the Office Action dated October 31, 2003, which was filed on February 2, 2004. Proper status identifiers for all claims are now provided.